

PATENTS *IJW*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Eric Bornstein
Application Serial No.: 10/776,106
Filing Date: February 11, 2004
Title: Near Infrared Microbial Elimination Laser System
Art Unit: 1651
Confirmation No.: 2676
Atty. Docket No.: 072287-0020

CERTIFICATE OF MAILING OR TRANSMISSION

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, or facsimile transmitted (571-273-8300) to the US PTO, on the date indicated below.

Date: 14 March 2007
Erin M. Olson

Mail Stop Amendment
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TRANSMITTAL LETTER

Enclosed for filing in connection with the above-referenced patent application is an Information Disclosure Statement by Applicant, with a copy of the cited reference attached.

No fees are believed due with this submission. However, the Commissioner is authorized to fees which may become due and/or credit any over payment to Deposit Account No. 50-1133.

Respectfully submitted,

Date: 14 March 2007
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Subst. for form 1449/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)			Complete if Known	
			Application Number	10/776,106
			Filing Date	February 11, 2004
			First Named Inventor	Bornstein
			Art Unit	1651
			Examiner Name	
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U.S. PATENT DOCUMENTS

Examiner Initials	Cite No. ¹	Document Number Number-Kind Code ²	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
		US 2003/0023284	01/30/2003	Garstein <i>et al.</i>	
		US 2003/0208249	11/06/2003	Chen	
		US 2004/0210276	10/21/2004	Altshuler <i>et al.</i>	
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U.S. PATENT DOCUMENTS CONT.

Examiner Initials	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ²			
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		Country Code ³ -Number ⁴ Kind Code ⁵ (if known)				
		WO 02/086550	10/31/2002	Haan et al.		
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				Examiner Name	
Sheet	3	of	3	Docket Number	072287-0020
FOREIGN PATENT DOCUMENTS CONT.					
		WO 2004/058352	07/14/2004	Palomar Medical Technologies, Inc.	
		WO 2006/076506	07/20/2006	Demetriou <i>et al.</i>	
Examiner Signature				Date Considered	

OTHER			
Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²
		LIANG, et al., Wavelength Dependence of Cell Cloning Efficiency after Optical Trapping, Biophy.J. March 1996, pp 1529-1533, Vol. 70	
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Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English Language Translation is attached. This collection of information is required by 37 CFR 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. Send to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 2231301450.